## Notice of References Cited Application/Control No. 10/565,805 Examiner MUHAMMAD SIDDIQUEE Applicant(s)/Patent Under Reexamination STELTER, MICHAEL Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2003/0203269 A1	10-2003	Rock, Jeffrey A.	429/37
*	В	US-6,533,827	03-2003	Cisar et al.	29/623.4
*	C	US-2002/0034673 A1	03-2002	Bisaka et al.	429/37
*	D	US-2003/0190226 A1	10-2003	Eaton et al.	414/796.4
*	Е	US-6,190,793 B1	02-2001	Barton et al.	429/34
*	F	US-2004/0081864 A1	04-2004	Herrmann, Manfred	429/013
*	G	US-2003/0041444 A1	03-2003	Debe et al.	29/623.1
	Ι	US-			
	-	US-			
	J	US-			
	K	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP11007975A	01-1999	JAPAN	Tadashi et al	H01M 8/24
	0					
	Р					
	Ø					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	W	
	×	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.